

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE****INFORMATION DISCLOSURE STATEMENT**

In re Patent Application of:	)	
Yoshito Katano	)	Group Art Unit: 2113
Application No. 10/597,353	)	Examiner: Yolanda L. Wilson
Filed: January 27, 2005	)	
For: <b>SEMICONDUCTOR DEVICE AND PROCESSING METHOD FOR STARTING THE SAME</b>	)	

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Commissioner For Patents  
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S I R:

In accordance with the provisions of 37 C.F.R. § 1.56, Applicants request that citation and examination of the references identified on the attached PTO-SB08A form, in accordance with 37 C.F.R. §1.98, be made during the course of examination of the above-referenced application for United States Letters Patent. These references were cited in an EP Communication issued on June 6, 2008, in connection with EP Application No. 200604823-5. Copies of the foreign references and English abstracts are attached as is a copy of the EP Communication.

Respectfully submitted,

/David R. Metzger/ (Reg. No. 32,919)

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